Mail Stop: Patent Application Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Doc. #: Mailing Date:

Dear Sir:

Transmitted herewith for filing is the patent application of:

Inventor(s):

SHING-CHYANG PAN

HSIEN-MING LEE CHING-HUA HSIEH

LI-LIN SU

JING-CHENG LIN

CHENG-LIN HUANG **CHAO-HSIEN PENG**

SHAU-LIN SHUE

For:

Pre-Clean Chamber With Wafer Heating Apparatus and Method of Use

Submitted herewith are:

- X 2 sheet(s) of formal drawings
- X An Assignment of the invention to Taiwan Semiconductor Manufacturing Co., Ltd., together with Assignment Recordal Sheet
- A Declaration for patent application under CFR 1.63 and 1.68

The filing fee has been calculated as shown below:

	No. Filed	No. Extra	Small Entity Fee	Large Entity Fee	Total
Basic Fee			\$385.00	\$770.00	\$770.00
Total Claims	20 X 20		\$9.00	\$18.00	\$0
Indep. Claims	3 -3		\$43.00	\$86.00	\$0
Multiple Dep. Clms.			\$145.00	\$290.00	\$0
Assign. Rec. Fee			\$40.00	\$40.00	\$40.00
TOTAL					\$810.00

Mailing Date: Feb. 27, 2004
Attorney Docket No.: 67, 200 - 1226

X	Attached is a Credit Card Payment Form for the sum of \$_	8	10.00
	A duplicate copy of this transmittal is attached.		`

- X The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Visa Credit Card No. <u>4756 8461 9568 0263</u>.
 - X Any additional filing fees required under 37 CFR 1.6 Any patent application processing fees under 37 CFR 1.17

Respectfully submitted,

TUNG & ASSOCIATES

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